



AF 896  
1/28/29

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: YOSHIDA, AKITO DOCKET NO.: W2K1077  
SERIAL NO: 10/082,472 EXAMINER: ZARNEKE  
FILED: 02/22/2002 ART UNIT: 2829  
TITLE: A STACKING STRUCTURE FOR SEMICONDUCTOR DEVICES  
USING A FOLDED OVER FLEXIBLE SUBSTRATE AND METHOD  
THEREFOR

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Mail Stop: Non-Fee Amendment

Commissioner For Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Weiss, Moy & Harris, P.C.

4204 North Brown Avenue

Scottsdale, Arizona 85251-3989

March 21, 2005

I hereby certify that on the 21<sup>st</sup> day of March, 2004,  
this correspondence is being deposited with the U.S.  
Postal Service as first class mail in an envelope  
addressed to: Commissioner for Patents, P.O. Box 1450  
Alexandria, VA 22313-1450.

  
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Jeffrey D. Moy

**AMENDMENT LETTER**

Dear Sir:

This is in response to an Office Communication dated March 2, 2005 dismissing Applicant's Appeal for the above identified patent application and issuing a Restriction Requirement.